



Acknowledgment to the Reviewers of *Applied Mechanics* in 2022

Applied Mechanics Editorial Office

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High-quality academic publishing is built on rigorous peer review. *Applied Mechanics* was able to uphold its high standards for published papers due to the outstanding efforts of our reviewers. Thanks to the efforts of our reviewers in 2022, the median time to first decision was 16 days and the median time to publication was 43 days. Regardless of whether the articles they examined were ultimately published, the editors would like to express their appreciation and thank the following reviewers for the time and dedication that they have shown *Applied Mechanics*:

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